

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Shunpei Yamazaki et al.)
)
Serial No.: 09/724,002)
)
Filed: November 28, 2000)
)
For: Film Deposition Apparatus And)
Method Of Manufacturing A Light)
Emitting Device Using The)
Apparatus)
)
Art Unit: 1792)
)
Confirmation No.: 7243)
)
Examiner: Karla A. Moore)

Commissioner for Patents
P.O. Box 1450
Alexandra, VA 22313-1450

AMENDMENT L (AFTER FINAL)

Sir:

Applicants have the following response to the Final Rejection of July 9, 2008, a two month extension of time and a RCE being submitted herewith.

Please amend in the above-identified application as follows: